

Instructions: _____ Seat Number _____

1. Do your own work. **DO NOT REMOVE THE STAPLE ON THIS EXAM.**
2. You may use a legal copy of the text by Massobrio and Antognetti. You may write notes in your text. You may NOT pass a book or note sheet to another student, or class notes or previously solved problems. **You may use your Project 3 solution and must submit it with this test in your exam packet.**
3. Calculator allowed. You may NOT share a calculator with another student.
4. Where values or equations are given on this cover sheet, use them in lieu of any other source. If a value is not given, explicitly state definitions and assumptions that you use.
5. Where possible, calculate parameters rather than read them from a graph.
6. Do all work in the spaces provided on this exam paper. If you write on the back of a sheet, make the notation "PTO" in your solution in order to assure that material written on the back of the page is evaluated for a grade. **AN EXTRA BLANK SHEET IS ATTACHED AT THE BACK OF THE EXAM.**
7. Show all calculations, making numerical substitutions and giving numerical results where possible.
8. **The total for the test is 75. Up to 25 additional points will be given for the Project report.**
9. Unless stated otherwise,

$T = 300\text{K},$	$V_t = 25.843 \text{ mV}$ (to agree with M&K k and q values)
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10. Unless otherwise stated, the material is silicon (300K) with

$n_i = 1.45\text{E}10 \text{ cm}^{-3}$	$N_c = 2.8\text{E}19 \text{ cm}^{-3}$	$q\chi_{\text{Si}} = 4.05 \text{ eV}$
$E_{g,\text{Si}} = 1.124 \text{ eV}.$	$N_v = 1.04\text{E}19 \text{ cm}^{-3}$	
11. For the work function of poly silicon, use

$\phi_{n+} = \chi_{\text{Si}} = 4.05 \text{ V}$
$\phi_{p+} = \chi_{\text{Si}} + E_{g,\text{Si}}/q = 5.174 \text{ V}.$
12. For minority carrier (either electrons or holes) lifetime in silicon, use the relationship

$$\tau_{\text{min}} = (4.5\text{E}-5 \text{ sec}) / (1 + N_i/1\text{E}17 + (N_i/5\text{E}17)^2),$$
 where N_i = the total impurity concentration in cm^{-3}
13. For holes in silicon doped primarily with boron*, assume

$$\mu_p = \{470.5 \div [1 + (N_i \div 2.23\text{E}17)^{0.719}]\} + 44.9, \text{ in cm}^2/\text{V-sec}.$$
14. For electrons in silicon doped primarily with phosphorous*, assume

$$\mu_n = \{1414 \div [1 + (N_i \div 9.2\text{E}16)^{0.711}]\} + 68.5, \text{ in cm}^2/\text{V-sec}.$$
15. For electrons in silicon doped primarily with arsenic, assume

$$\mu_n = \{1417 \div [1 + (N_i \div 9.68\text{E}16)^{0.68}]\} + 52.2, \text{ in cm}^2/\text{V-sec}.$$

(In 12 through 15, N_i = the total impurity concentration in n- or p-type material, compensated or not.)
 (*13 may be used as an approximation for holes as minority carriers, likewise *14 for minority electrons.)
16. Metal gate work functions should be assumed to be

$\phi_{\text{M,Al}} = 4.1 \text{ V}$ for aluminum,	$\phi_{\text{M,Pt}} = 5.3 \text{ V}$ for platinum,	$\phi_{\text{M,Au}} = 4.75 \text{ V}$ for gold
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17. The electron affinity of SiO_2 is $\chi_{\text{SiO}_2} = 1.00 \text{ V}.$
18. Planck constant $h = 6.625\text{E}-34 \text{ J-s} = 4.135\text{E}-15 \text{ eV-s},$ (1 eV = 1.602E-19 Joule).
19. free electron mass $m_o = 9.11\text{E}-28 \text{ g}.$
20. Boltzmann constant, $k = 1.38\text{E}-23 \text{ J/K}$
21. Electron charge, $q = 1.602\text{E}-19 \text{ Coulomb}$
22. Permittivity of free space, $\epsilon_o = 8.854\text{E}-14 \text{ Fd/cm}$
23. Relative permittivity of silicon, $\epsilon_r = 11.7$
24. Relative permittivity of silicon dioxide, $\epsilon_{\text{rOx}} = 3.9$
25. The breakdown voltage of an abrupt (step) junction (asymmetrical or one-sided) diode with doping on the lightly doped side of N_B is $V_B = 60(E_g/1.1)^{3/2} (10^{16}/N_B)^{3/4} \text{ V}.$ The critical field for breakdown is modeled as $E_{\text{crit}} = (120\text{V} \cdot qN_B / (\epsilon_r \epsilon_o))^{1/2} \cdot (E_g/1.1)^{3/4} \cdot (10^{16}/N_B)^{3/8}$
26. Each part is worth [x] points, as given in the problem.